502062728 09/14/2012

PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
SERGEY SOFER	04/28/2010
MICHAEL PRIEL	04/28/2010
DOV TZYTKIN	04/28/2010

RECEIVING PARTY DATA

Name:	FREESCALE SEMICONDUCTOR INC
Street Address:	6501 WILLIAM CANNON DRIVE WEST
City:	AUSTIN
State/Country:	TEXAS
Postal Code:	78735

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	13635166

CORRESPONDENCE DATA

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Mail.

Correspondent Name: FREESCALE SEMICONDUCTOR, INC. LAW DEPART

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ATTORNEY DOCKET NUMBER:	NM45841EC
NAME OF SUBMITTER:	ROSEMARY HOFFERT

Total Attachments: 4

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ASSIGNMENT AND AGREEMENT

For good and valuable consideration, the receipt of which is hereby acknowledged, we, SOFER SERGEY, RESHON LETZION, PRIEL MICHAEL, HERTZELIA, ISRAEL, ISRAEL and TZYTKIN DOV, NESS ZYIONA, ISRAEL have sold, assigned and transferred, and do hereby sell, assign and transfer, unto FREESCALE SEMICONDUCTOR, INC., a corporation of the State of Delaware, having its principal office in Austin, Texas, United States of America, and its successors, assigns, and legal representatives, the entire right, title and interest for the United States of America in and to certain inventions relating to improvements in YOLTAGE
YOLTAGE
LEVEL SHIFTER, AND VOLTAGE
SHIFTING METHOD
(Docket No. NM45841EC-USA)), described, illustrated and claimed in an application for Letters Patent of the United States of America executed by us on the dates indicated by our signatures below, together with the entire right, title and interest in and to the application, and in and to Letters Patent which may be issued upon the application, and upon any division, extension, continuation or reissue thereof.">YOLTAGE
YOLTAGE
YOLTAGE
YOLTAGE
SHIFTING METHOD
(Docket No. NM45841EC-USA)), described, illustrated and claimed in an application for Letters Patent of the United States of America executed by us on the dates indicated by our signatures below, together with the entire right, title and interest in and to the application, and upon any division, extension, continuation or reissue thereof.

We hereby also sell, assign and transfer unto FREESCALE SEMICONDUCTOR, INC., the entire right, title and interest in and to the invention and in and to applications for Letters Patent therefor in all countries foreign to the United States of America, including all rights under any and all international conventions and treaties in respect of the invention and the applications for Letters Patent in foreign countries, and we further authorize FREESCALE SEMICONDUCTOR, INC. to apply for Letters Patent in foreign countries directly in its own name, and to claim priority of the filing date of the application for Letters Patent of the United States of America under the provisions of any and all international conventions and treaties.

We hereby authorize and request the Commissioner of Patents of the United States of America to issue Letters Patent upon the aforesaid application, division, extension, continuation or reissue, to FREESCALE SEMICONDUCTOR, INC., for the sole use and benefit of FREESCALE SEMICONDUCTOR, INC., its successors, assigns and legal representatives, to the full end of the term for which Letters Patent may be granted, the same as they would have been held and enjoyed by me had this assignment not been made, and we hereby authorize and request the equivalent authorities in foreign countries to issue the patents of their respective countries to FREESCALE SEMICONDUCTOR, INC.

We agree that, when requested, we will, without charge to FREESCALE SEMICONDUCTOR, INC., but at its expense, sign all papers, take all rightful oaths, and do all acts which may be necessary, desirable or convenient for securing and maintaining patents for the

NM45841EC-USA

inventions in any and all countries and for vesting title thereto in FREESCALE SEMICONDUCTOR, INC., its successors, assigns and legal representatives or nominees.

We covenant with FREESCALE SEMICONDUCTOR, INC., its successors, assigns and legal representatives, that the interest and property hereby conveyed is free from all prior assignment, grant, mortgage, license or other encumbrance.

SOFER SERGEY	DATE: <u>Apr 28 2010</u>
First Witness SIGNATURE OF WITNESS NOKHIMOVITCH MICHAEL	DATE: Apr 28 2010 (Month-Day-Year)
PRINTED NAME OF WITNESS	

Second Witness	
SIGNATURE OF WITNESS	DATE: Apr 28 2010 (Month-Day-Year)
LANDA ROMAN PRINTED NAME OF WITNESS	_

PRIEL MICHAEL	DATE: <u>Apr 28 2010</u>
First Witness SIGNATURE OF WITNESS	DATE: Apr 28 2010 (Month-Day-Year)
NOKHIMOVITCH MICHAEL PRINTED NAME OF WITNESS	
Second Witness SIGNATURE OF WITNESS	DATE: <u>Apr 28 2010</u> (Month-Day-Year)

LANDA ROMAN
PRINTED NAME OF WITNESS

TZYTKIN DOV	DATE: <u>Apr 28 2010</u>
First Witness SIGNATURE OF WITNESS	DATE: <u>Apr 28 2010</u> (Month-Day-Year)
NOKHIMOVITCH MICHAEL PRINTED NAME OF WITNESS	
Second Witness SIGNATURE OF WITNESS	DATE: <u>Apr 28 2010</u> (Month-Day-Year)
LANDA ROMAN PRINTED NAME OF WITNESS	(MOHUI-Day-1 cal)

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